



**ELECTRONIC COPY**

LG791644532  
Report verification at igi.org



April 28, 2026  
IGI Report Number **LG791644532**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **6.11 X 6.09 X 4.42 MM**  
**GRADING RESULTS**  
Carat Weight **1.45 CARAT**  
Color Grade **G**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

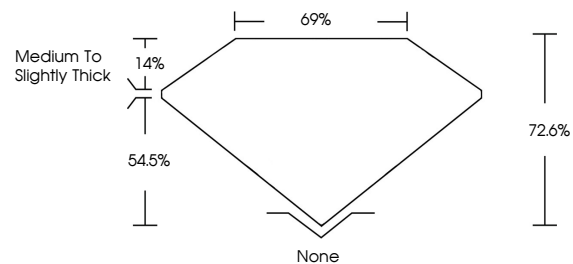
Carat Weight **1.45 CARAT**  
Color Grade **G**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG791644532**

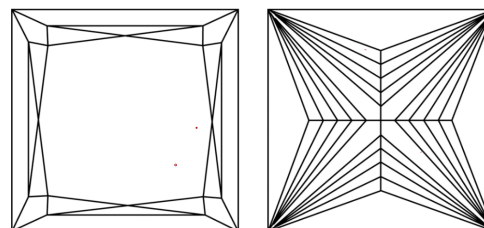
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

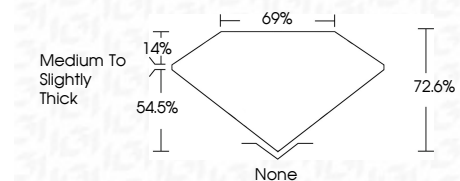
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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**PRINCESS CUT**  
6.11 X 6.09 X 4.42 MM  
Carat Weight **1.45 CARAT**  
Color Grade **G**  
Clarity Grade **VVS 2**  
Depth **54.5%**  
Table **14%**  
Girdle **Medium to Slightly Thick**  
Culet **None**  
Polish **VERY GOOD**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG791644532**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa